



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takua NAKAMURA

Group Art Unit: 3739

Application No.: 10/080,712

Examiner: David M. Shay

Filed: February 25, 2002

Docket No.: 111856

For: METHOD FOR ASSESSING IRRADIATION INTENSITY OF A LASER BEAM, AN APPARATUS FOR ASSESSING IRRADIATION INTENSITY USED UNDER THIS METHOD, AND A LASER BEAM IRRADIATION SYSTEM

**SUPPLEMENTAL AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the September 24, 2003 Office Action, and as a supplement to the Amendment filed on March 24, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**